

In re the Application of: **Hiroshi TANABE**

Filed: : **Concurrently herewith**

For : **METHOD FOR FORMING SEMICONDUCTOR FILMS AT DESIRED  
POSITIONS ON A SUBSTRATE**

Serial No.: **Concurrently herewith**

July 12, 2000

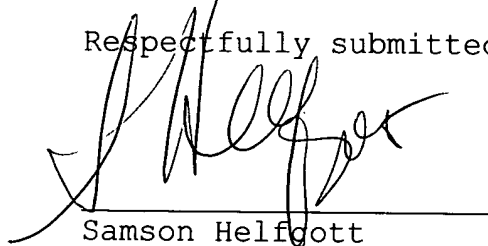
Assistant Commissioner of Patents  
Washington, D.C. 20231

**SUB-POWER OF ATTORNEY**

S I R:

I, Samson Helfgott, Reg. No. 23,072 attorney of record herein, do hereby grant a sub-power of attorney to Linda S. Chan, Reg. No. 42,400, Jacqueline M. Steady, Reg. No., 44,354 and Harris A. Wolin, Reg. No. 39,432 to act and sign in my behalf in the above-referenced application.

Respectfully submitted,



Samson Helfgott  
Reg.No 23,072

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By: Lydia Gonzalez  
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